

Docket No.: 051319-0047

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.:

10/607,594

Title:

SLACK-FORMING MECHANISM

FOR STATOR COIL

Applicant:

Taiichi Miya et al.

Filed:

June 27, 2003

Examiner:

Thiem D. Phan

Art Unit:

3729

Confirmation No.:

5978

Mail Stop Issue Fee Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Date of Deposit: June 28, 2006

I hereby certify that this paper or fee is being deposited with the United States Postal Service "First Class Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated above and is addressed to Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

Signatures

Sarah Schlie

## COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

Sir:

The Applicants submit that the invention set forth in each of the claims is patentable for reasons set forth in the specification of the present application as well as for all of the reasons set forth in the remarks submitted during prosecution of this Application.

Respectfully submitted, SCHULTE ROTH & ZABEL LLP Attorneys for Applicant 919 Third Avenue New York, NY 10022 (212)756-2000

By

Anna Vishev

Reg. No.: 45,018

Dated:

June 28, 2006

New York, New York